§ 63.7090

comply with the emission limitations no later than January 5, 2004, and you must have completed all applicable performance tests no later than July 5, 2004.

- (2) If you start up your affected source after January 5, 2004, then you must comply with the emission limitations for new affected sources upon startup of your affected source and you must have completed all applicable performance tests no later than 180 days after startup.
- (b) If you have an existing affected source, you must comply with the applicable emission limitations for the existing affected source, and you must have completed all applicable performance tests no later than January 5, 2007
- (c) If you have an LMP that is an area source that increases its emissions or its potential to emit such that it becomes a major source of HAP, the deadlines specified in paragraphs (c)(1) and (2) of this section apply.
- (1) New affected sources at your LMP you must be in compliance with this subpart upon startup.
- (2) Existing affected sources at your LMP must be in compliance with this subpart within 3 years after your source becomes a major source of HAP.
- (d) You must meet the notification requirements in §63.7130 according to the schedule in §63.7130 and in subpart A of this part. Some of the notifications must be submitted before you are required to comply with the emission limitations in this subpart.

EMISSION LIMITATIONS

$\S 63.7090$ What emission limitations must I meet?

- (a) You must meet each emission limit in Table 1 to this subpart that applies to you.
- (b) You must meet each operating limit in Table 2 to this subpart that applies to you.

GENERAL COMPLIANCE REQUIREMENTS

§ 63.7100 What are my general requirements for complying with this subpart?

(a) After your initial compliance date, you must be in compliance with the emission limitations (including operating limits) in this subpart at all times, except during periods of startup, shutdown, and malfunction.

- (b) You must be in compliance with the opacity and visible emission (VE) limits in this subpart during the times specified in 63.6(h)(1).
- (c) You must always operate and maintain your affected source, including air pollution control and monitoring equipment, according to the provisions in §63.6(e)(1)(i).
- (d) You must prepare and implement for each LMP, a written operations, maintenance, and monitoring (OM&M) plan. You must submit the plan to the applicable permitting authority for review and approval as part of the application for a 40 CFR part 70 or 40 CFR part 71 permit. Any subsequent changes to the plan must be submitted to the applicable permitting authority for review and approval. Pending approval by the applicable permitting authority of an initial or amended plan, you must comply with the provisions of the submitted plan. Each plan must contain the following information:
- (1) Process and control device parameters to be monitored to determine compliance, along with established operating limits or ranges, as applicable, for each emission unit.
- (2) A monitoring schedule for each emission unit.
- (3) Procedures for the proper operation and maintenance of each emission unit and each air pollution control device used to meet the applicable emission limitations and operating limits in Tables 1 and 2 to this subpart, respectively.
- (4) Procedures for the proper installation, operation, and maintenance of monitoring devices or systems used to determine compliance, including:
- (i) Calibration and certification of accuracy of each monitoring device;
- (ii) Performance and equipment specifications for the sample interface, parametric signal analyzer, and the data collection and reduction systems;
- (iii) Ongoing operation and maintenance procedures in accordance with the general requirements of §63.8(c)(1), (3), and (4)(ii); and
- (iv) Ongoing data quality assurance procedures in accordance with the general requirements of §63.8(d).